

3. Tecnologia de Vácuo

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POSMAT – Unesp/Bauru

O que vimos na aula passada ? [\[aula 06\]](#)

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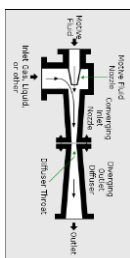
Resumo

- Vácuo $\equiv$ baixas pressões
- bombas de vácuo
- vedações

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... do mais simples ...

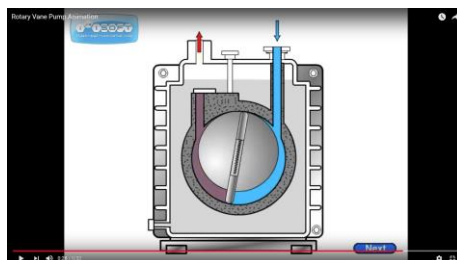
WATER JET PUMP 0.23 m³h⁻¹



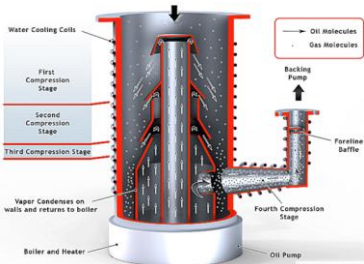
http://physics.kenyon.edu/EarlyApparatus/Pneumatics/Vacuum_Pump/Vacuum_Pump.html



<https://www.youtube.com/watch?v=AFHogF-9eGA>



Bomba scroll

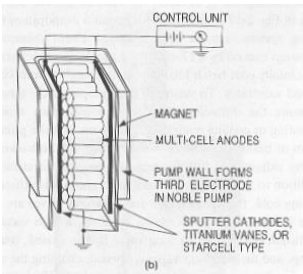
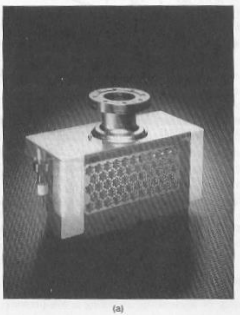


STP MAGNETICALLY LEVITATED TURBOMOLECULAR PUMPS

... ao mais sofisticado....

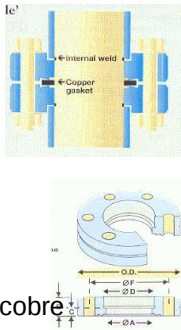


5-axis control The STP600, STP1000, STP2001 and all the high throughput pumps (H-C), utilise a full 5 active axis system with electromagnets for all bearings. This patented, fully active system allows an automatic balancing system to be used.



- Bombas iônicas e de sublimação

Ultra alto vácuo (UHV, $p \sim 10^{-6} - 10^{-11}$ torr)



Selo metálico – Anéis de cobre (CONFLAT)

Resumindo:

- ⇒ Há diferentes tecnologias disponíveis para gerar baixas pressões ("vácuo")
- ⇒ Cada tipo de bomba é adequada para uma determinada faixa de pressões
- ⇒ Os sistemas de vácuo devem ser pensados pela pressão final e pela quantidade de fluido bombeado !

3.2 Tecnologia de Vácuo

[aula 07]

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- (a) Medidores de pressão
- (b) Analisadores de gases
- (c) Regimes de escoamento
- (d) Medidores de Fluxo
- (c) Exercícios – Caps. 2 e 3
- 3.3 (b) Vazão e veloc. de bombeamento¹⁴

- 3.2 (a) Medidores de pressão

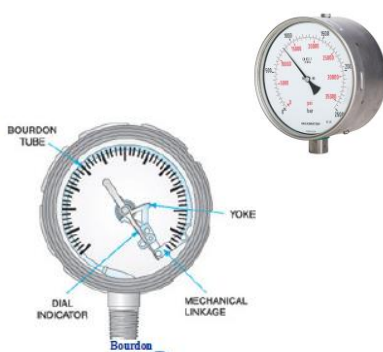
Pressões acima da atmosférica

Manômetros tipo Bordon



P: Como esses medem a pressão?

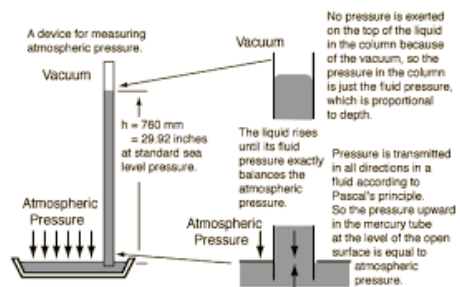
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KJL Technical notes

(língua de sogra)

Pressão atmosférica



$$1\text{ATM} = 760 \text{ mm Hg} = 1.01 \times 10^5 \text{ Pa (N/m}^2\text{)}$$

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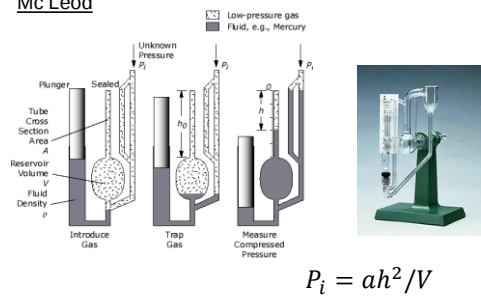
Baixas pressões

McLeod

1 bar = 10⁵ Pa (N/m²) ~ 1 ATM

1 torr = 133 Pa = 1.33 mbar

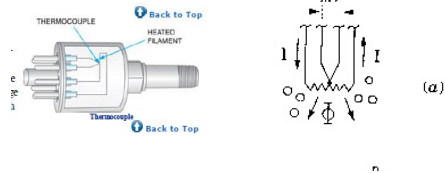
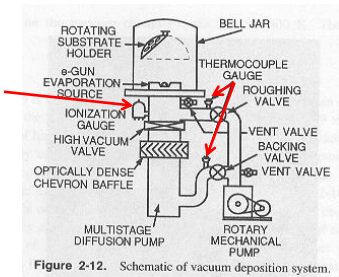
1 psi (libra/polegada²) = 7.000 Pa = 52 torr



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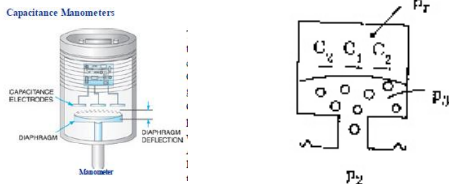
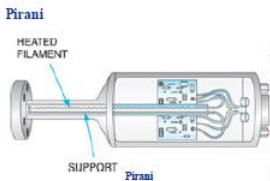
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termopar



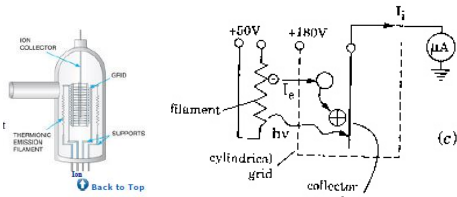
$p_{ATM} \sim 10^{-2} \text{ torr}$

capacitância

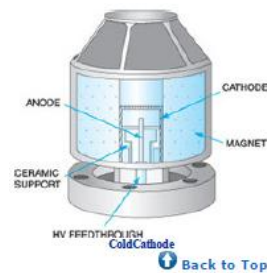


1 - 10⁻⁴ torr

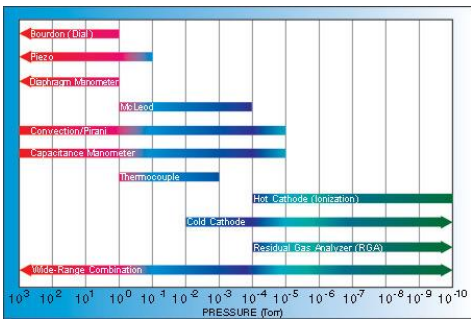
Iônico / Hot filament



$10^{-3} - 10^{-11}$ torr



Range – medidores de pressão



Medidores de Pressão

Conclusão:
* os medidores de pressão (vácuo) têm suas escalas típicas.

Analizador de gases residuais

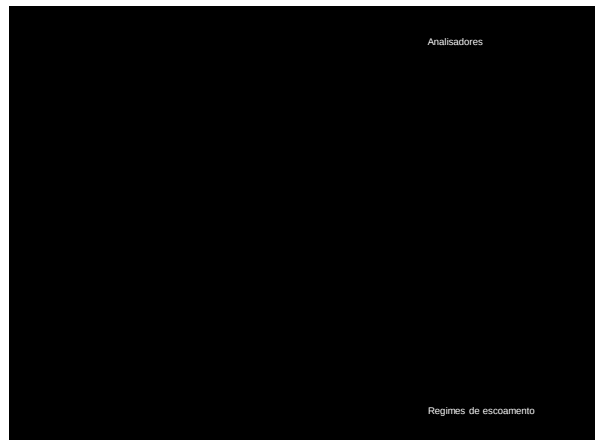
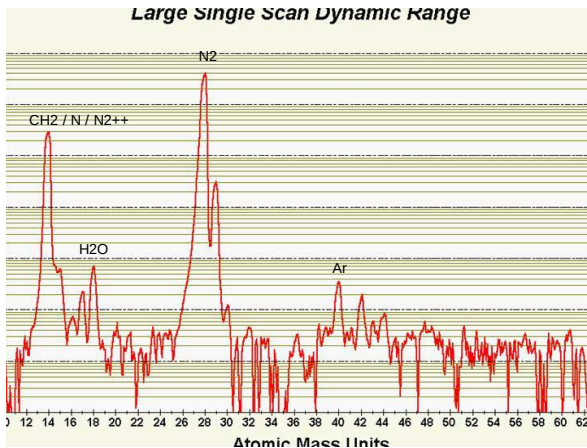


- 100, 200 and 300 amu systems
- Better than 1 amu resolution
- 6 decades of dynamic range
- 5×10^{-11} Torr detection limit
- RGA Windows & LabVIEW software
- Field-replaceable electron multiplier and filament
- RS-232 interface

$p_{res} \sim 10^{-2} - 10^{-12}$ torr

- Medidores de pressão
- 3.2 (b) Analisadores de gases
- Regimes de escoamento
- Medidores de Fluxo
- Exercícios – Cap. 3

Analizador de gases residuais



- Medidores de pressão
- Analísadores de gases
- 3.2 (c) Regimes de escoamento
- Medidores de Fluxo
- Exercícios – Cap. 3

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Regimes de Escoamento

$$K_n = \frac{l}{L}$$

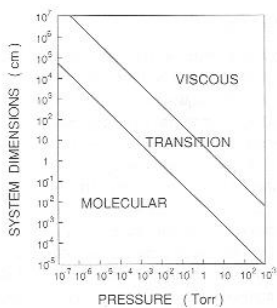
l = livre caminho médio

L = tamanho do sistema

Número de Knudsen:

- $K_n > 1$ – alto vácuo, colisões molécula-paredes (molecular)
- $K_n \ll 0,01$ – fluxo de fluido, colisões molécula-molécula (fluido / viscoso)
- $0,01 \ll K_n < 1$ – regime intermediário

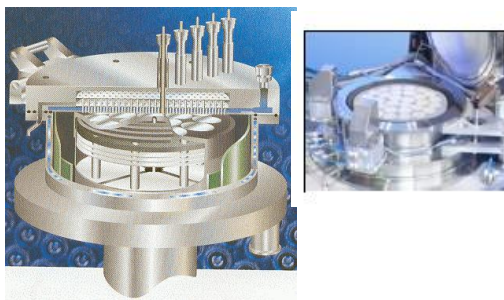
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Regimes de fluxo de gás dominantes em função das dimensões do sistema e pressão

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Reator CVD complexo (comercial)



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Fluxo de gás / Inomogeneidades

322 Chemical Vapor Deposition

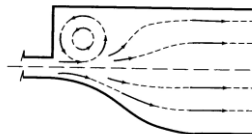


Figure 7.7 Two alternative reactor-entrance geometrie patterns (upper and lower halves). The upper pattern avoided.

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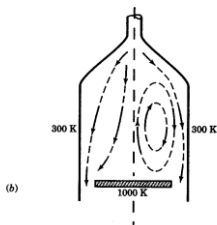


Figure 7.12 Typical free-convection cell: (a) horizontal rectangular-tube reactor (view along axis) with two alternate sidewall conditions, insulated (left) and cooled (right); (b) downflow axisymmetric reactor, showing two alternate flow patterns. In (b), the recirculating pattern (right) is to be avoided.

Distribuição de velocidades nas proximidades do susceptor (porta substratos).

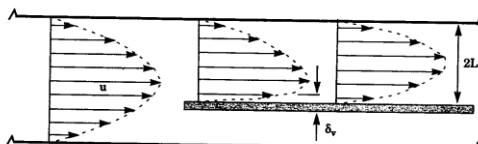


Figure 7.8 Velocity boundary layer of width δ_v forms at the susceptor leading edge in a tube reactor.

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Linhas de fluxo de gás / simetria axial

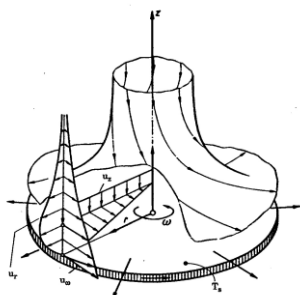


Figure 7.10 Axisymmetric flow pattern over a rotating disc. (Source: Reprinted from Ref. 7 by permission, © 1968 by McGraw-Hill Book Co.)

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3.3 Tecnologia de Vácuo

- Medidores de pressão
- Analisadores de gases
- Regimes de escoamento
- 3.3 (a) Controladores de Fluxo
- Vazão e velocidade de bombeamento
- Exercícios – Cap. 3

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